IN THE UNITED STATES PATENT AND TRADEMARK OFFICE.

Applicants: Yeo, et al. Docket No.: TSM03-0926

Serial No.: 10/685.938 Art Unit: 2894

Filed: October 15, 2003 Examiner: Movva, Amar

For: Dummy Pattern for Silicide Gate Electrode

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING RCE

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated July 24, 2008, which Action is made final, and the Advisory Action mailed October 7, 2008. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 C.F.R. § 1.114, and respectfully request reconsideration of the claims.

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